

REPORT DOCUMENTATION PAGE			Form Approved OMB NO. 0704-0188	
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1. AGENCY USE ONLY (Leave blank)		2. REPORT DATE 4/18/2000		3. REPORT TYPE AND DATES COVERED Interim Report, 1/1/99 - 12/31/99
4. TITLE AND SUBTITLE New Microlayer and Lanolayer Polymer Composites			5. FUNDING NUMBERS DAAG55-98-1-0311	
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7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) Case Western Reserve University 10900 Euclid Avenue Cleveland, Ohio 44106-7202			8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING / MONITORING AGENCY NAME(S) AND ADDRESS(ES) U.S. Army Research Office P.O. Box 12211 Research Triangle Park, NC 27709-2211			10. SPONSORING / MONITORING AGENCY REPORT NUMBER	
11. SUPPLEMENTARY NOTES The views, opinions and/or findings contained in this report are those of the author(s) and should not be construed as an official Department of the Army position, policy or decision, unless so designated by other documentation.				
12a. DISTRIBUTION / AVAILABILITY STATEMENT Approved for public release; distribution unlimited.				
13. ABSTRACT (Maximum 200 words) The highlights of this period are centered around the development of polymer nanolayer systems by a novel continuous coextrusion method. Nanolayers ranging in thickness between 5 nm to 500 nm have been manufactured using inexpensive polymeric materials such as polystyrene, polystyrene acrylonitrile copolymers, polypropylene, polyethylene, polycarbonate and polymethylmethacrylate. Two and three component systems have been made from various combinations of these polymers. In particular, the morphology of polypropylene has been drastically changed from a routine spherulitic α -form structure to a discoidal meso-form structure by just decreasing the layer thickness to nano dimensions. High density polyethylene has been totally changed to a "shish-kabab" structure due to the fact that the nano-layer thickness is less than the radius of gyration of the polymer macromolecule. When oriented, this novel crystalline morphology appeared as extended chain fibrillar crystals imbedded in polystyrene acting as the continuous phase in a nanocomposite structure. Recently, we have started to develop nano-systems with anisotropic electrical and mechanical properties. Also, gradient and vertical layer structures are being considered. In the last few weeks we have actually succeeded in creating a vertical composite with highly anisotropic mechanical properties composed of polystyrene and a styrene-butadiene block copolymer.				
14. SUBJECT TERMS			15. NUMBER OF PAGES	
			16. PRICE CODE	
17. SECURITY CLASSIFICATION OF REPORT UNCLASSIFIED			18. SECURITY CLASSIFICATION OF THIS PAGE UNCLASSIFIED	
19. SECURITY CLASSIFICATION OF ABSTRACT UNCLASSIFIED			20. LIMITATION OF ABSTRACT UL	

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1. Publications:

S. Nazarenko, A. Hiltner, E. Baer, *Polymer Microlayer Structures with Anisotropic Conductivity*, J. Mater. Sci., **34**, 1461-1470 (1999).

T. Schuman, S. Nazarenko, E.V. Stepanov, S.N. Maganov, A. Hiltner, E. Baer, *Solid State Structure and Melting Behavior of Interdiffused Polyethylene in Microlayers*, Polymer **40**, 7373-7385 (1999).

J. Kerns, A. Hsieh, E. Baer, A. Hiltner, Mechanical Behavior of Polymer Microlayers, in Mechanical Behavior of Polymeric Materials (J. Kahovec, ed.), Macromol. Symp. 147-Wiley-VCH, pp. 15-25 (1999).

D. Jarus, E. Baer, A. Hiltner, Relationship of Hierarchical Structure to Mechanical Properties, in Mechanical Behavior of Polymeric Materials (J. Kahovec, ed.), Macromol. Symp. 147, Wiley-VCH, pp. 37-61 (1999).

S. Nazarenko, M. Dennison, T. Schuman, E.V. Stepanov, E. Baer, A. Hiltner, *Creating Layers of Concentrated Inorganic Particles by Interdiffusion of Polyethylene in Microlayers*, J. Appl. Polym. Sci., **73**, 2877-2885 (1999).

A. Hiltner, E. Baer, J. Kerns, Processing and Properties of Polymer Microlayered Systems, in Structure Development during Polymer Processing (A.M. da Cunha, ed.), Kluwer, The Netherlands (in press)

L. Flandin, E. Baer and A. Hiltner, *Interrelationships between Electrical and Mechanical Properties of a Carbon Black-Filled Ethylene-Octene Elastomer*, Polymer, (in press)

J. Kerns, A. Hsieh, E. Baer, A. Hiltner, *Comparison of Irreversible Deformation and Yielding in Microlayers of PC with PMMA and SAN*, J. Appl. Polym. Sci., (in press)

L. Flandin, A. Chang, S. Nazarenko, E. Baer, A. Hiltner, *Effect of Strain on the Properties of an Ethylene-Octene Elastomer with Conductive Carbon Fillers*, J. Appl. Polym. Sci., (in press)

L Flandin, A. Hiltner, E. Baer, *Interrelationships between Electrical and Mechanical Properties of a Carbon Black-Filled Ethylene-Octene Elastomer*, Polymer (submitted)

Oral Presentations:

New Polymer Microlayer Composites, invited lecture at NATO ASI Conference on Structure Development in Processing for Polymer Property Enhancement, Caminha, Portugal, June 17-28, 1999.

Microlayer Coextrusion Technology, plenary paper presented at SPE ANTEC '99, New York, May 2-9, 1999.

Invited lecturer on "Processing of Polymer Microlayered Systems," NATO-ASI Conference on Structure Development in Processing for Polymer Property Enhancement, Universidade do Minho-Azurem, Guimaraes, Portugal, May 17-28, 1999.

Invited lecturer on "Polymer Microlayer Coextrusion and Composites," XVIII Plastics Seminar, Grande Hotel de Luso, Lisbon, Portugal, May 28-29, 1999.

Invited lecturer on "New Topics in Microlayered Composites," International Paper, Cincinnati, OH, July 13, 1999.

Invited lecturer on "Microlayer Structures with Anisotropic Conductivity," Twenty-Second Asilomar Conference on Polymeric Materials, Pacific Grove, CA, February 14-17, 1999.

2. list of PI's, students, and postdocs supported under the grant

Undergraduate Students

S. Norek, A. Hasan, A. Shah, M. Dennison

Graduate Students

C. Mueller, T. Ebeling, T. Schuman, J.A. Kerns

Postdoctoral Research Associates

S. Nazarenko, E.V. Stepanov, L. Flandin

3. awards and honors from the past year

Michael Dennison won the best poster prize at the 1999 National Engineers Week for his poster on *Microlayer Gradient Structures with Concentrated Filler Particles*.

4. description of interactions with ARL scientists during past year

- Alex Hsieh - ballistics
- Jo Ann Ratto - biodegradation

5. list of significant technology transfer activities with industry or Army labs during past year

6. short summary of most notable accomplishments, breakthroughs, and technology transfer events during the past year under the program

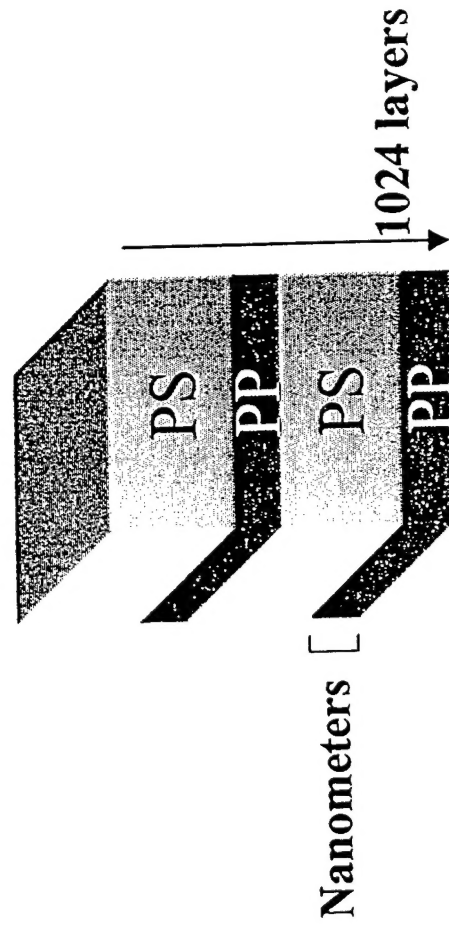
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7. 1-2 view graphs that highlight recent accomplishments (Powerpoint slides)

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Novel Nanolayered Films

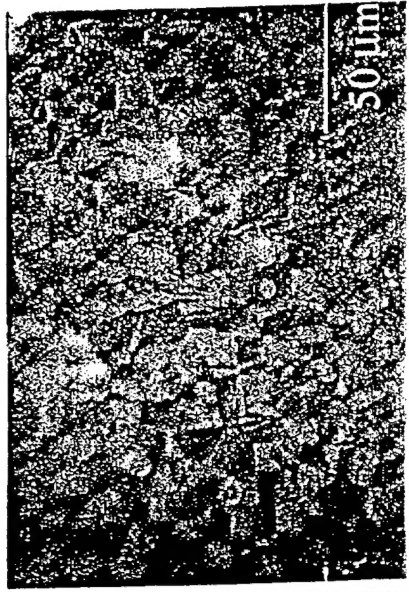
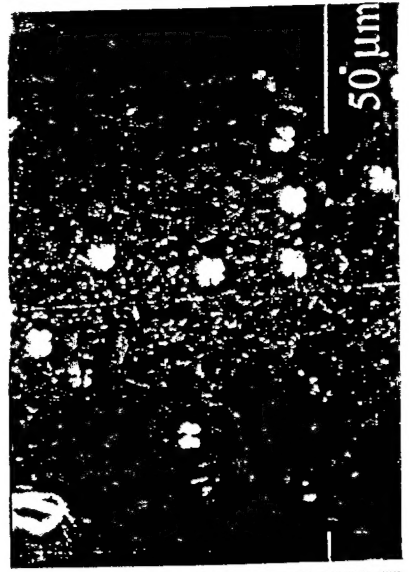
PP/PS Microlayered System



Composition PP/PS	Film Thickness (mils)		
	1	5	10
	<i>Calculated PP Layer Thickness (nm)</i>		
100/0	--	--	--
90/10	50	220	450
80/20	--	200	--
50/50	--	120	--
20/80	9	50	100
10/90	5	30	50

Microlayering is a unique method for achieving films where the layer thickness can be controlled from the micro to the nanoscale. As the film thickness is decreased, limitation on the crystal growth in the third dimension occurs at different hierarchical scales.

PP/PS 90/10 10 mils PP/PS 10/90 10 mils PP/PS 10/90 1 mil



T 450 nm

50 nm

5 nm

D/T 60

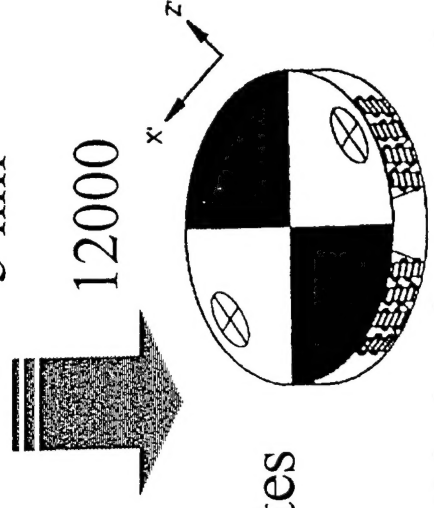
640

12000

T = Calculated PP Layer Thickness

D = Discoid Diameter

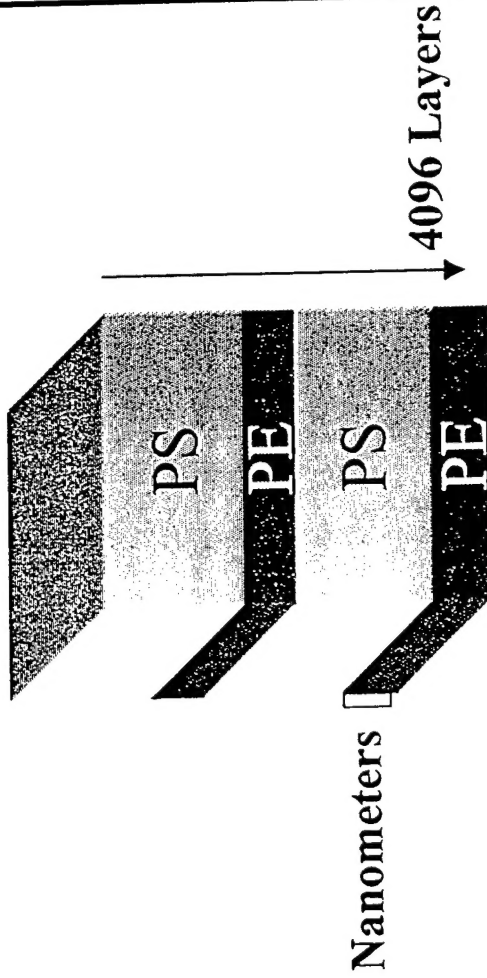
Discoid Spherulites



As PP layer thickness decreases, constraint on the spherulitic level occurs, and two-dimensional spherulites (discoids) are obtained. Orientation of this nanolayered film would decrease PP layer thickness an order of magnitude, causing mixing of the components on the molecular scale.

Novel Molecular Composite

HDPE/PS Microlayered System

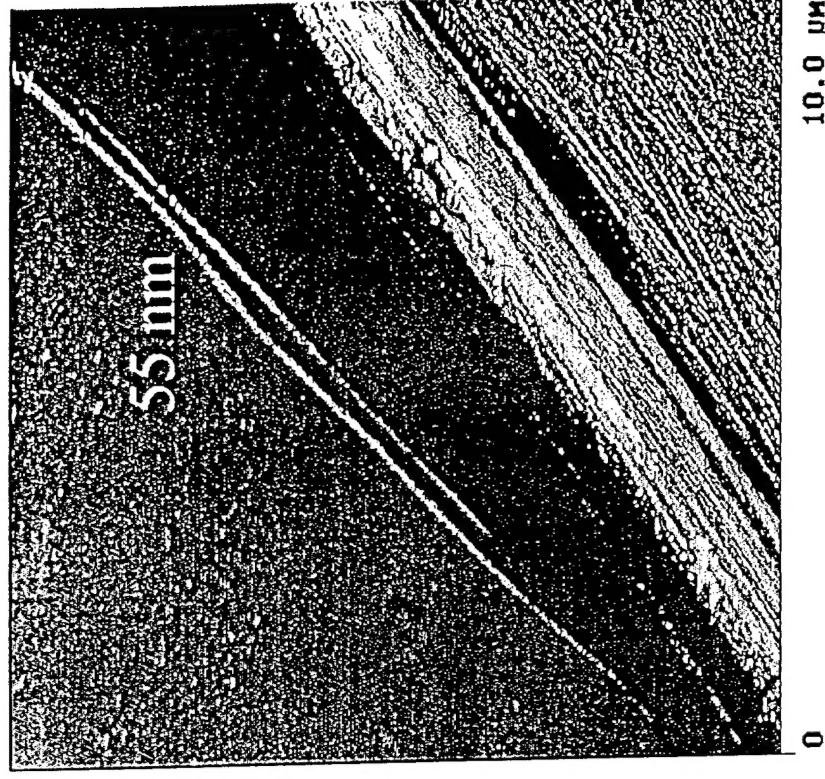
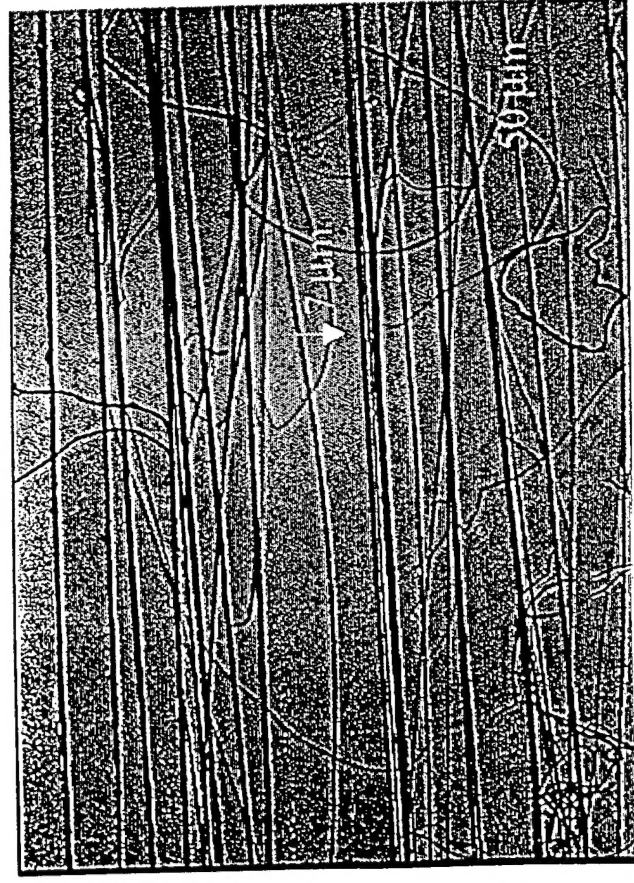


System	Nanolayer 4096 Layers	Microlayer 128 Layers
Composition HDPE/PS	<i>Film Thickness (mils)</i>	
	10	2
	10	2
	<i>Calculated HDPE Layer Thickness</i>	
	(nm)	(μm)
100/0	--	--
30/70	37	1.2
20/80	25	1.30
10/90	12	0.40
5/95	6	0.20
0/100	--	--

There is great scientific interest in ultrathin layers, where the layer thickness is decreased to the scale of a few nanometers and is comparable with the radius of gyration of the polymer molecules.

Optical Microscope

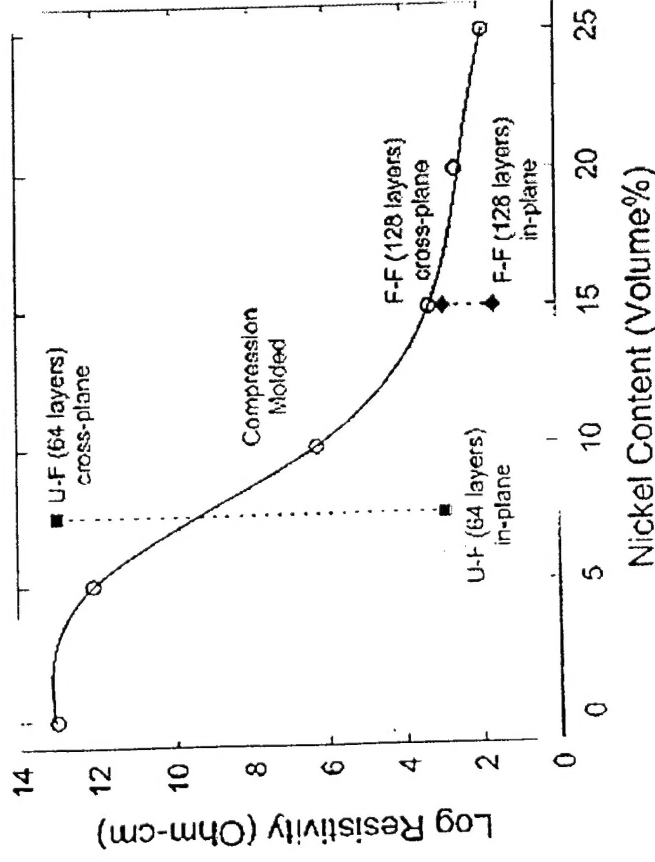
Atomic Force Microscope



HDPE/PS, 5/95, 4096 Layers, 2 mil thick

This novel crystalline morphology of nanolayers appeared as extended-chain fibrillar crystals. Orientation of such system at high temperature will create a fiber reinforced molecular composite.

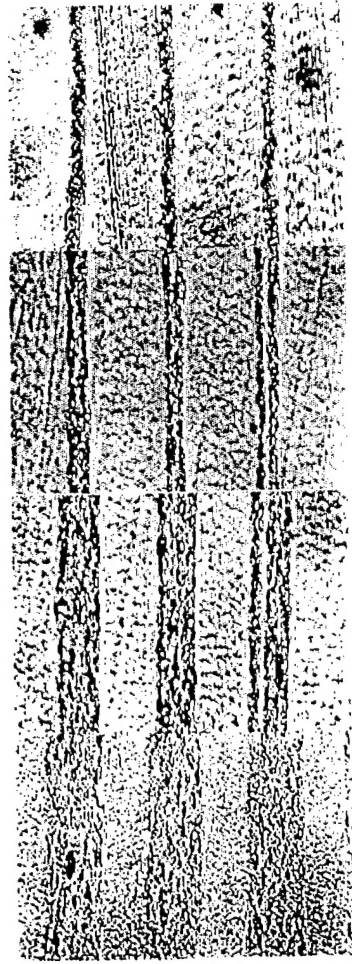
Anisotropic Electrical Properties



Microlayers having highly anisotropic electrical properties were created

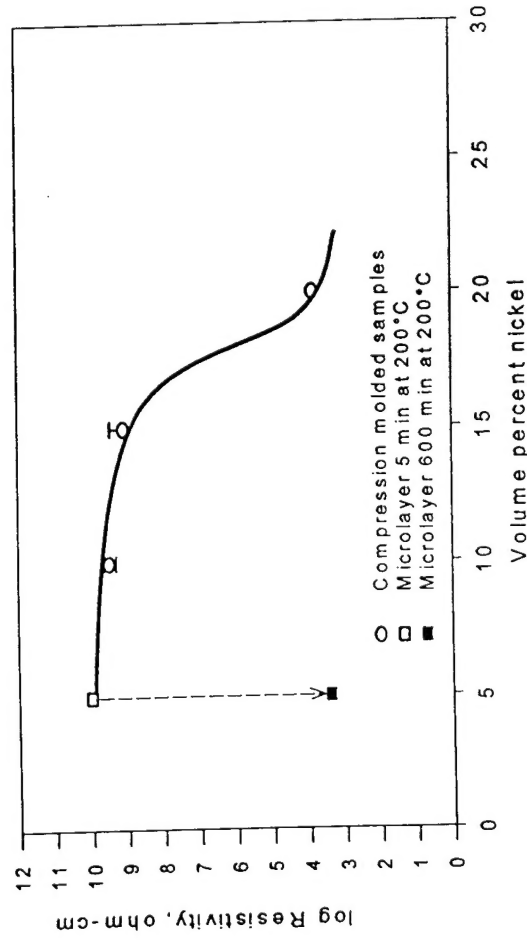
In-plane and cross-plane resistivity of the microlayers differed by ten orders of magnitude

- A non-conductive system of nickel in polyethylene was microlayered using a low amount of filler
- After annealing the samples in the melt, interdiffusion of the layers created a moving boundary, subsequently concentrating the particles to a point above the percolation threshold.



Optical micrographs of filled-unfilled PE microlayers annealed in the melt for 0, 5, 600, 3000, and 10000 minutes

Electrical behavior of unfilled-filled and filled-filled microlayers superimposed on resistivity versus volume fraction for nickel platelets

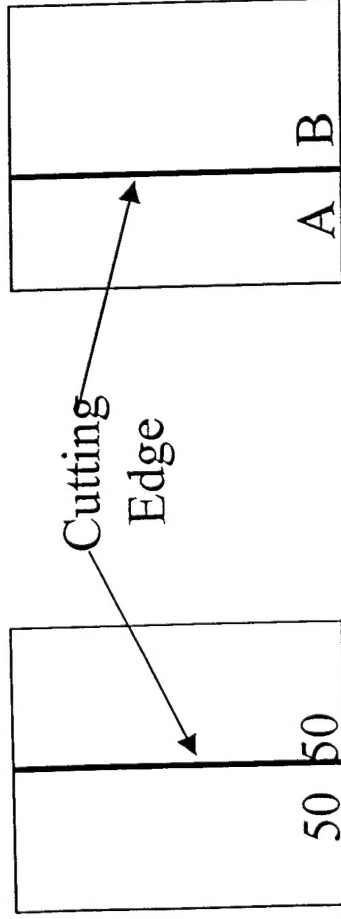


- These anisotropic conductive systems have application in EMI shielding, electronic switching, solid-state batteries, and ESD protection.
- Concentrating systems can extend to a wide range of filler types, particularly those that exhibit poor processability at high loading.

Gradient Microlayer Structures



Microlayered films that exhibit a gradient in layer thickness can be achieved with new multiplier design



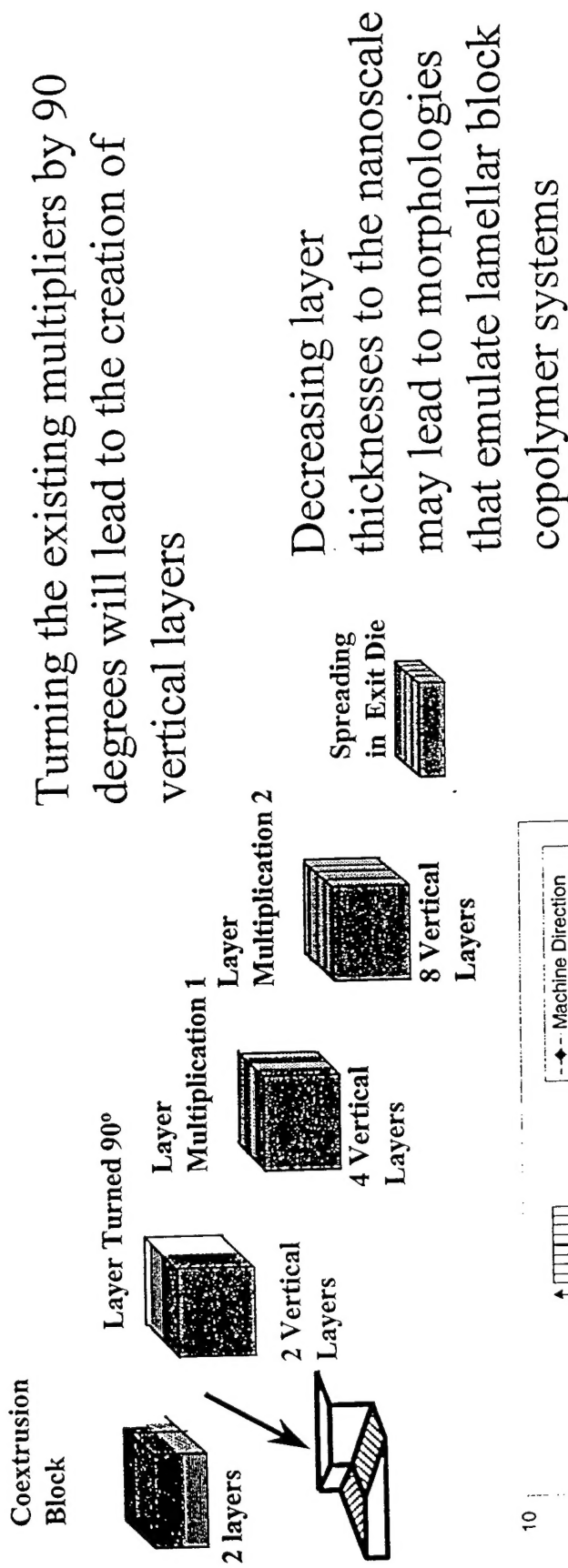
Current multiplier Gradient multiplier
 $A \neq B$

This can be accomplished by increasing the B/A ratio in each subsequent multiplier, as illustrated.

With 6 multiplier die elements, layer thicknesses would differ by a factor of 50

This geometry can be tailored to create films having novel transport properties, or unique optical, electrical, and mechanical properties

Vertical Microlayers



This structure can exhibit highly anisotropic mechanical properties, as exemplified in the PS/Kraton 512 layer system shown here.

